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22386 US PTO
10/750023

Atty. Docket No.: AB-1350 US

December 31, 2003

Mail Stop Patent Application
 Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

Enclosed herewith for filing is a patent application, as follows:

Inventor: LEE, Ho
 Title: CHEMICAL VAPOR DEPOSITION APPARATUS

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 This Transmittal Letter (in duplicate)
~~4~~ page(s) Specification and ~~1~~ page(s) Title Page (not including claims)
~~2~~ page(s) Claims
~~1~~ page Abstract
~~2~~ sheet(s) of Drawings (consisting of Figs. 1, 2, and 3)
~~2~~ page(s) Declaration for Patent Application and Power of Attorney
~~1~~ page(s) Change of Correspondence Address

CLAIMS AS FILED

For	Number <u>Filed</u>	Number <u>Extra</u>	Rate \$18.00	Basic Fee
Total Claims	9	-20 = 0	X	\$ 770.00 \$ 0.00

Independent Claims	2	-3 = 0	X	\$ 86.00	\$ 0.00
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Fee of _____ for the first filing of one or more multiple dependent claims per application \$

Fee for Request for Extension of Time \$

Please make the following charges to Deposit Account No. 50-2257:

Total fee for filing the patent application in the amount of \$ 770.00
 The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-2257.

EXPRESS MAIL LABEL NO:

EV 302 216 405 US

Respectfully submitted,

David W. Heid
 Attorney for Applicant
 Reg. No. 25,875

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: LEE, Ho

Assignee: Samsung Electronics Co., Ltd.

Title: CHEMICAL VAPOR DEPOSITION APPARATUS

Application No.: Unknown Filing Date: Herewith

Examiner: Unknown Group Art Unit: Unknown

Docket No.: AB-1350 US

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Alexandria, VA 22313-1450

CHANGE OF CORRESPONDENCE ADDRESS

Dear Sir:

Pursuant to 37 C.F.R. § 1.33(a)(2), the undersigned principal attorney of record hereby requests that the correspondence address for the above-referenced patent application be changed to:

David W. Heid
MacPherson Kwok Chen & Heid LLP
1762 Technology Drive, Suite 226
San Jose, CA 95110

The daytime telephone number of the undersigned Attorney for Applicant is (408) 392-9250. The Examiner is requested to telephone the undersigned Attorney for Applicant, if the Examiner has any question regarding the above.

Respectfully submitted,



David W. Heid
Attorney for Applicant
Reg. No. 25,875

EXPRESS MAIL LABEL NO.:

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